

Application Data Sheet

Application Information

Application number::

Filing Date::

Application Type::

Regular

Subject Matter::

Utility

Title ::

LASER IRRADIATION
METHOD, LASER
IRRADIATION APPARATUS
AND METHOD FOR
MANUFACTURING
SEMICONDUCTOR DEVICE

Attorney Docket Number::

0756-7283

Total Drawing Sheets::

15

Small Entity?::

No

Applicant Information

Applicant Authority Type::

Inventor

Primary Citizenship Country::

Japan

Given Name::

Koichiro

Middle Name::

Family Name::

TANAKA

Name Suffix::

City of Residence::

Atsugi

State or Province of Residence::

Kanagawa

Country of Residence::

Japan

Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd.
398, Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan
Given Name:: Hidekazu
Middle Name::
Family Name:: MIYAIRI
Name Suffix::
City of Residence:: Tochigi
State or Province of Residence:: Tochigi
Country of Residence:: Japan
Street of mailing address:: c/o Semiconductor Energy
Laboratory Co., Ltd.
398, Hase
City of mailing address:: Atsugi-shi
State or Province of mailing address:: Kanagawa-ken
Country of mailing address:: Japan
Postal or Zip Code of mailing address:: 243-0036

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Japan

Given Name:: Hironobu
 Middle Name::
 Family Name:: SHOJI
 Name Suffix::
 City of Residence:: Machida
 State or Province of Residence:: Tokyo
 Country of Residence:: Japan
 Street of mailing address:: c/o Semiconductor Energy
 Laboratory Co., Ltd.
 398, Hase
 City of mailing address:: Atsugi-shi
 State or Province of mailing address:: Kanagawa-ken
 Country of mailing address:: Japan
 Postal or Zip Code of mailing address:: 243-0036

Correspondence Information

Correspondence Customer Number :: 31780
 E-Mail address:: erobinson@riplo.com

Representative Information

Representative Customer Number:: 31780

Domestic Priority Information

Application ::	Continuity Type::	Parent Application::	Parent Filing Date::

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2003-101312	04/04/2003	Yes

Assignee Information

Assignee name:: Semiconductor Energy
Laboratory Co., Ltd.

Street of mailing address:: 398 Hase

City of mailing address:: Atsugi-shi

State or Province of mailing address:: Kanagawa-ken

Country of mailing address:: Japan

Postal or Zip Code of mailing address:: 243-0036